

HT-02-016

January 22, 2004

To: Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/706,381 11/12/03 |
Moris Dovek et al.
WRITE-HEAD HAVING RECESSED MAGNETIC
MATERIAL IN GAP REGION
| _____ |

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first class
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P.O. Box 1450, Alexandria, VA 22313-1450, on January 27, 2004.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

SB Ackerman 1/27/04

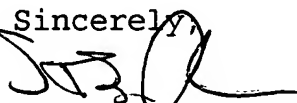
U.S. Patent 6,353,511 to Shi et al., "Thin Film Write Head for Improved High Speed and High Density Recording," discloses a process for a improved write head.

U.S. Patent 5,878,481 to Feng et al., "Pole Trimming Method for Fabricating a Magnetic Transducer Structure," discloses a pole trimming process for a write head.

U.S. Patent 5,843,521 to Ju et al., "Photoresist Frame Plated Magnetic Transducer Pole Layer Employing High Magnetic Permeability Seed Layer," discloses a method for forming a magnetic transducer, and a magnetic transducer formed through the method.

U.S. Patent 5,802,700 to Chen et al., "Method of Making a Planarized Thin Film Magnetic Write Head with Submicron Trackwidth," discloses a method for making a thin film magnetic write head with a notch stucture located on top of one of two pole layers.

U.S. Patent 5,652,687 to Chen et al., "Planarized Thin Film Magnetic Write Head with Submicron Trackwidth," discloses a planarized write head process.

Sincerely,

Stephen B. Ackerman,
Reg. No. 37761

Form PTO-1449

Docket Number (Optional)

HT-02-016

Application Number

10/706,381

Applicant

Moris Dorek et al.

Filing Date

11/12/03

Group Art Unit

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6353511	3/5/02	Shi et al.	360	126	6/15/99
	5878481	3/9/99	Feng et al.	29	603.15	4/28/97
	5843521	12/1/98	Ju et al.	427	129	7/21/97
	5802700	9/8/98	Chen et al.	29	603.14	6/6/95
	5652687	7/29/97	Chen et al.	360	126	9/21/95

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.